

PATENT

CR/2812

Case Docket No. ASMMC.036AUS
Date: January 8, 2002



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : SOPHIE et al.

Appl. No. : 09/975,466

Filed : October 9, 2001

For : IN SITU REDUCTION OF
COPPER OXIDE PRIOR TO
SILICON CARBIDE
DEPOSITION

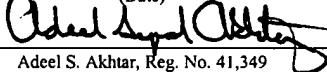
Examiner : Unknown

Group Art Unit : 2812

I hereby certify that this correspondence and all
marked attachments are being deposited with the
United States Postal Service as first class mail in an
envelope addressed to: Commissioner for Patents,
Washington, D.C. 20231, on

January 8, 2002

(Date)


Adeel S. Akhtar, Reg. No. 41,349

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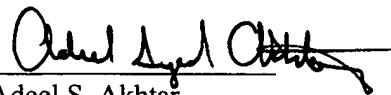
TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A Form PTO-1449 with thirty-seven (37) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.


Adeel S. Akhtar
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Attorney of Record